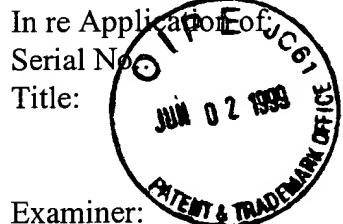


GP 2877

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Todd A. Cerni et al.

09/296,928

CHEMICAL MECHANICAL PLANARIZATION (CMP)  
SLURRY QUALITY CONTROL PROCESS AND PARTICLE  
SIZE DISTRIBUTION MEASURING SYSTEMS

Not Assigned

7009/018CP

**CERTIFICATION UNDER 37 CFR §1.10**

I hereby certify that this communication and the documents referred to as attached herein are being deposited with the United States Postal on this date June 2, 1999 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR 1.10, Mailing Label Number EL288975504US addressed to the: Assistant Commissioner of Patents, Washington, D.C. 20231.

Nancy Halas  
(type of print name of person mailing paper)

Nancy Halas  
(Signature of person mailing paper)

**RECEIVED**

Box Non Fee Amendment  
Assistant Commissioner for Patents  
Washington, DC 20231

JUN 09 1999

TECHNOLOGY CENTER 2800

**PRELIMINARY AMENDMENT**

Dear Sir:

Applicants request a change of title of the above-referenced application. Please change the title to: CHEMICAL MECHANICAL PLANARIZATION (CMP) SLURRY QUALITY CONTROL PROCESS AND PARTICLE SIZE DISTRIBUTION MEASURING SYSTEMS. Support for this amendment is provided in the Field of Invention of the original specification.

No fees are deemed due in connection with this Preliminary Amendment. However, the Commissioner is hereby authorized to charge any fees which may be due in this matter from Deposit Account Number 04-1697.

Respectfully submitted,  
Duft, Graziano & Forest, P.C.

By: Curtis A. Vock  
Curtis A. Vock, Reg. No. 38,356  
1790 - 30<sup>th</sup> Street, Suite 140  
Boulder, Colorado 80301  
Tel: (303) 449-9497  
Fax: (303) 449-0814